



DOCKET NO: VSEA 02-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Daniel F. Downey et al.
Serial No: 09/996,446
Confirmation No: 2412
Filed: November 28, 2001
For: ATHERMAL ANNEALING WITH RAPID THERMAL
ANNEALING SYSTEM AND METHOD
Examiner: Jermele M. Hollington
Art Unit: 2829

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 13 day of January, 2005.


Cheryl Purcell

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

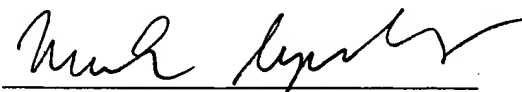
Sir:

Petition for Extension of Time

A three-month extension of time to January 13, 2005 is requested for response to the Examiner's Office Action of July 13, 2004.

The extension fee of \$1020.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,
Daniel F. Downey et al., Applicants

By: 
Mark A. Superko, Reg. No. 34,027
Varian Semiconductor Equipment
Associates, Inc.
35 Dory Rd.
Gloucester, Massachusetts 01930-2297
Telephone: (978) 282-5915

Docket No. VSEA 02-01

01/19/2005 55TH181 00000046 500896 09996446

01 FC:1253 1020.00 DA